

6AU/761-#4
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

John E. Lang

Application No.: 09/274,194

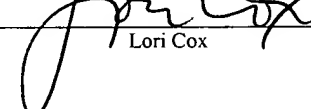
Filed: March 22, 1999

For: METHOD OF REMOVING PHOTORESIST MATERIAL
WITH DIMETHYL SULFOXIDE

) Attorney Docket No.: 60265/308301
)
) Examiner: C. Brown
)
) Group Art Unit: 1765
)
) Date: February 23, 2001
)
)
)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, Washington, DC 20231 on February 23, 2001.

Signed: 
Lori Cox

Commissioner for Patents
Washington, DC 20231

Sir:

Transmitted herewith is an amendment in the above-identified application.

- ☒ Applicant(s) hereby petition for a ONE month extension of time to respond to the outstanding Office Action.
- ☒ Applicant(s) believe that a ONE Month Extension of Time is required and we authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 02-3964. (Order No. 60265/308301 (LAM1P083A)). A copy of this sheet is enclosed.

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Respectfully submitted,
OPPENHEIMER WOLFF & DONNELLY, LLP



Robert D. Hayden
Registration No. 42,645

P.O. Box 52037
Palo Alto, CA 94303-0746
Telephone: (650) 470-7430

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